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MMC Activities

Micro / Nano 2008: An Overview

Micromachine Center (MMC)

To promote industrial interchange in micro/nano fields (micromachines, MEMS etc.) as effectively as possible, the Micromachine Center is sponsoring Micro/Nano 2008, an integrated event that includes an exhibition, conference and related events. Micro/Nano 2008 will provide attendees with an overview of the latest technical and industry trends in micro/nano fields as well as the opportunity to conduct business exchanges efficiently with micro/nano related organizations and companies from Japan and overseas countries. Micro/Nano 2008 will be held for four days starting Tuesday, July 29, 2008 and ending Friday, August 1, 2008 with Tokyo Big Sight as the main venue.

1. Micro/Nano 2008 Organization and Schedule

Exhibition

The 19th Exhibition Micromachine/MEMS

International Exhibition focusing on MEMS, Nanotechnology, Ultraprecision / Microfabrication and Biotechnology

Date July 30, 2008 (Wednesday) - August 1, 2008 (Friday)

Venue Tokyo Big Sight (Tokyo International Exhibition Center, West Hall 1 & 2)

Sponsor Micromachine Center
Organizer Mesago Messe Frankfurt Corporation

Support (planned) Ministry of Economy / Trade and Industry (METI)
Cooperation (planned) The Japan Machinery Federation / Japan Robot Association
Japan Analytical Instruments Manufacturers Association

Concurrent Events

◆ The 14th International Micromachine / Nanotech Symposium

Date & Time July 29, 2008 (Tuesday) 10:00 a.m. - 6:10 p.m.

Venue Tokyo Bay Ariake Washington Hotel (Iris Banquet Hall)

Sponsor Micromachine Center
Support (planned) Ministry of Economy, Trade and Industry (METI), New Energy and Industrial Technology Development Organization (NEDO)
Cooperation (planned) The Japan Machinery Federation / Japan Robot Association / Japan Analytical Instruments Manufacturers Association

◆ Japanese-German Micro / Nano Business Forum

Date & Time July 30, 2008 (Wednesday) 10:45 a.m. - 5:00 p.m.

Venue Tokyo Big Sight (Tokyo International Exhibition Center, West Hall 1)
19th Exhibition Micromachine / MEMS special venue

Sponsor IVAM Microtechnology Network **Cosponsor** Micromachine Center / MEMS Industry Forum

◆ Meeting for announcing results of FineMEMS Project

Date & Time July 31, 2008 (Thursday) 12:30 - 4:30 p.m.

Venue Tokyo Big Sight (Tokyo International Exhibition Center, West Hall 1)
19th Exhibition Micromachine / MEMS special venue

Sponsor Fine MEMS Project Promotion Committee / Micromachine Center
Cosponsor New Energy and Industrial Technology Development Organization (NEDO)

◆ MEMS Forum

Date & Time August 1, 2008 (Friday) 10:30 a.m. - 4:35 p.m.

Venue Tokyo Big Sight (Tokyo International Exhibition Center, West Hall 1)
19th Exhibition Micromachine / MEMS special venue

Sponsor Micromachine Center / MEMS Industry Forum